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## facsimile transmittance

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To: Examiner Erik J. Kielin Fax: 703-872-9306  
 From: Mag Chappuis Date: February 4, 2004  
 E-mail: Mchappuis@atmi.com Pages: 11 (including transmittal)  
 Re: Response to August 15, 2003 Office cc:  
 Action in U. S. Patent Application  
 No. 09/823,196

### OFFICIAL COMMUNICATION

RESPONSE TO AUGUST 15, 2003 OFFICE ACTION IN UNITED STATES PATENT  
 APPLICATION NO. 09/823,196 AND  
 PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Dear Examiner Kielin:

Please find the following documents enclosed:  
 Response to August 15, 2003 Office Action - 10 sheets  
 Transmittal - 1 sheet

Please call 203-739-1435 if there are any problems with this transmittal.

Maggie Chappuis

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 ATMI Docket: ATM-S10

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICERECEIVED  
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|  |   |   |
|--|---|---|
| In re United States Patent Application of: | )   |   |
| Applicants:                                | Thomas H. Baum et al.   | ) |
| Serial No.:                                | 09/823,196  | ) |
| Date Filed:                                | March 30, 2001  | ) |
| Title:                                     | SOURCE REAGENT COMPOSITIONS<br>FOR CVD FORMATION OF GATE<br>DIELECTRIC THIN FILMS USING<br>AMIDE PRECURSORS AND METHOD<br>OF USING SAME | ) |

Docket No.: ATMI-510

Examiner: Erik J. Kielin

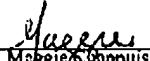
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Maguire Chappuis

February 4, 2004  
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**RESPONSE TO AUGUST 15, 2003 OFFICE ACTION IN UNITED STATES PATENT  
APPLICATION NO. 09/823,196 AND  
PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 15, 2003, applicant respectfully requests entry of the following Amendments and consideration of the subsequent remarks.